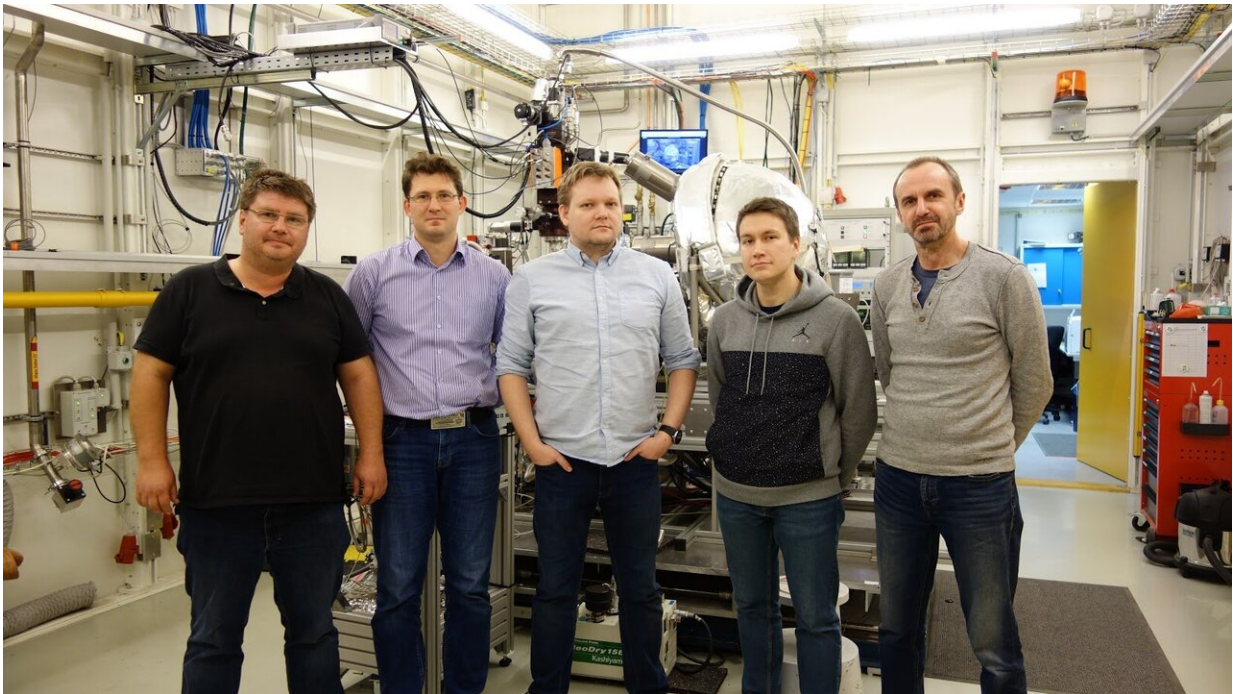


Researchers close in on new nonvolatile memory

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Members of the research team that conducted the experiment, standing in front of the high-energy X-ray photoemission spectroscopy setup at the PETRA III synchrotron in Hamburg, Germany. Left to right: Andrei Gloskovskii, Yury Matveyev, Dmitry Negrov, Vitalii Mikheev, and Andrei Zenkevich. Credit: Andrei Zenkevich/MIPT

Researchers from the Moscow Institute of Physics and Technology, along with their colleagues from Germany and the U.S., have achieved a

breakthrough in nonvolatile memory devices. The team came up with a unique method for measuring the electric potential distribution across a ferroelectric capacitor, which could lead to the creation of memory orders of magnitude faster than current flash and solid-state drives, withstanding 1 million times as many rewrite cycles. The paper was published in *Nanoscale*.

Hafnium dioxide-based memory is based on a dielectric already known to the microelectronics industry. Subjected to temperature treatment and alloying, a nanometer-scale hafnium dioxide layer can form metastable crystals that possess [ferroelectric properties](#)—that is, they "remember" the direction of the electric field applied to them.

The new memory cell is a zirconium-hafnium oxide film 10 nanometers thick interlaid between two electrodes. Its structure resembles a conventional electric capacitor. To make ferroelectric capacitors usable as [memory cells](#), their remnant polarization has to be maximized; and to ensure that, engineers need a detailed understanding of the processes that occur in the nanofilm. This involves explaining how the [electric potential](#) is distributed across the film following voltage application and polarization reversal. Since the discovery of a ferroelectric phase in hafnium oxide 10 years ago, the potential distribution at the nanoscale has only been modeled, but not directly measured. The latter has been reported in the recent paper in *Nanoscale*.

The team employed a technique known as high-energy X-ray photoemission spectroscopy. The specialized methodology developed at MIPT relies on the so-called standing-wave mode of the powerful monochromatic X-ray beam, which requires a synchrotron light source to produce. The machine used in the study is located in Hamburg, Germany. It was used to perform measurements on the hafnium oxide-based memory cell prototypes manufactured at MIPT.

"If used for the industrial production of nonvolatile memory cells, the ferroelectric capacitors developed in our lab could endure 10 billion rewrite cycles, which is 100,000 times more than state-of-the-art flash drives can survive," said study co-author Andrei Zenkevich, who heads the Laboratory of Functional Materials and Devices for Nanoelectronics at MIPT.

A further advantage of ferroelectric memory devices is that external radiation has absolutely no effect on them, unlike their semiconductor-based analogues. This means that the flash-like [memory](#) of the future could even weather cosmic ray exposure and operate in outer space.

More information: Yury Matveyev et al. Polarization-dependent electric potential distribution across nanoscale ferroelectric Hf_{0.5}Zr_{0.5}O₂ in functional memory capacitors, *Nanoscale* (2019). [DOI: 10.1039/C9NR05904K](https://doi.org/10.1039/C9NR05904K)

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